

Improved electrodeposition of CdS layers in presence of activating H₂SeO₃ microadditive

Maricheva, Jelena; Bereznev, Sergei; Naidu, Revathi; Maticiuc, Natalia; Mikli, Valdek; Kois, Julia Materials science in semiconductor processing 2016 / p. 14-19 : ill <https://doi.org/10.1016/j.mssp.2016.06.013> [Journal metrics at Scopus](#) [Article at Scopus](#)
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